SUBSTITUTE FORM PTO-1449 (MODIFIED)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. TPS-012	SERIAL NO. 10/814,713
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		APPLICANT Raymond Joe et al.	
(37 CFR 1.98(b))		FILING DATE March 31, 2004	GROUP 1762

(Stamp: COPY — MAY 26 2005 — JC-48 — PATENT & TRADEMARK)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.A	6 4 1 3 3 2 1	07/02/2002	Kim et al.	118	725	12/07/2000
	A.B						
	A.C						
	A.D						
	A.E						
	A.F						
	A.G						
	A.H						
	A.I						
	A.J						
	A.K						

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION (YES/NO)
	A.L	2003051452	02/21/2003	EP	H01L	21/205	Abstract Only
	A.M	2003051533	02/21/2003	EP	H01L	21/68	Abstract Only
	A.N	2003100743	04/04/2003	EP	H01L	21/318	Abstract Only
	A.O						
	A.P						
	A.Q						

OTHER DOCUMENTS (Including Author, Title, Date, Place of Publication)

	A.R	Bolscher et al., Pre-Treatment of Reactor Parts for Chemical Vapor Deposition Reactors, US 2002/0058108 A1; publication date 05/16/2002; filed 11/07/2001; U.S. Class 427/299
	A.S	Rossman, Si Seasoning to Reduce Particles, Extend Clean Frequency, Block Mobile Ions and Increase Chamber Throughput, US 2003/0211735 A1; publication date 11/13/2005; filed 06/16/2003; U.S. Class 438/680
	A.T	

EXAMINER	/Bret Chen/	DATE CONSIDERED	05/30/2008

EXAMINER: Initial if citation considered, whether or not in conformance. Draw line through citation only if not in conformance and not considered. Include a copy of this form with next communication to Applicant.

Substitute Disclosure Form (PTO-1449)

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /BC/